

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Scherer et.al.

Examiner: R. McDonald

Serial No:

10/068,283

Art Unit: 1753

Filed:

February 5, 2002

Title:

DRY ETCHING AND MIRROR

DEPOSITION PROCESSES FOR SILICONE ELASTOMER

Date: May 14, 2004

CERTIFICATE OF MAILING VIA FIRST CLASS MAIL

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Date of Deposit: May 14, 2004

I hereby certify that the following documents as identified below are being deposited with the United States Postal Service with sufficient postage for first class mail in an envelope addressed to: Mail Stop _____, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450:

1. Correction of Amendment

The above-identified document is enclosed herewith.

Respectfully submitted,

Date: May 14, 2004

John Nguyen

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Scherer et.al.

Serial No.: 10/068,283

Filed: Feb. 5, 2002

For: Dry Etching and Mirror

Deposition Processes for Silicone

Elastomer

Examiner: R.McDonald Group Art Unit: 1753

CORRECTION OF AMENDMENT

Hon. Commissioner of Patents and Trademarks Washington DC 20231

Sir:

In reply to the Notice of April 26, 2004 please replace the amendments to the claims with the appended section.